

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L8	395	438/7.ccls.	US-PGPUB; USPAT	OR	OFF	2006/03/30 08:48
L9	5667	250/491.1.ccls. 250/492.22.ccls. 257/797.ccls. 430/22.ccls. 430/30. ccls. 438/7.ccls. 438/16.ccls.	US-PGPUB; USPAT	OR	OFF	2006/03/30 09:03
L10	28821	((registation align\$8) with mark) fiducial	US-PGPUB; USPAT	OR	ON	2006/03/30 09:03
L11	551	L10 same (image with detect\$6) same illuminat\$6	US-PGPUB; USPAT	OR	ON	2006/03/30 09:03
L12	78	L9 and L11	US-PGPUB; USPAT	OR	ON	2006/03/30 09:03
L13	14894	((registation align\$8) with mark) fiducial	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/30 09:19
L14	176	L13 and (image with detect\$6) and illuminat\$6	EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/03/30 09:19
L15	129	L10 same (image with detect\$6) same illuminat\$6 same (substrate wafer) same (expos\$6 pattern\$6) same (layer film resist photoresist mask photomask)	US-PGPUB; USPAT	OR	ON	2006/03/30 09:29
L17	31	(((registation align\$8) with mark) fiducial) and (image with detect\$6) and illuminat\$6 and (substrate wafer) and (expos\$6 pattern\$6) and (layer film resist photoresist mask photomask)). clm.	US-PGPUB	OR	ON	2006/03/30 09:51
L18	43	((mark fiducial) and (image with detect\$6) and illuminat\$6 and (substrate wafer) and (expos\$6 pattern\$6) and (layer film resist photoresist mask photomask)). clm.	US-PGPUB	OR	ON	2006/03/30 09:52